

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Masakazu NISHIYAMA, et al.

SERIAL NUMBER: 10/585,945

GROUP: 1621

FILED: July 11, 2006

EXAMINER: DAVIS, BRIAN J

FOR: AMINE COMPOUND HAVING FLUORENE GROUP AS FRAMEWORK,  
PROCESS FOR PRODUCING THE AMINE COMPOUND, AND USE OF THE  
AMINE COMPOUND

**REQUEST FOR PRIORITY ACKNOWLEDGMENT UNDER 35 U.S.C. 119**  
**AND THE INTERNATIONAL CONVENTION**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
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SIR:

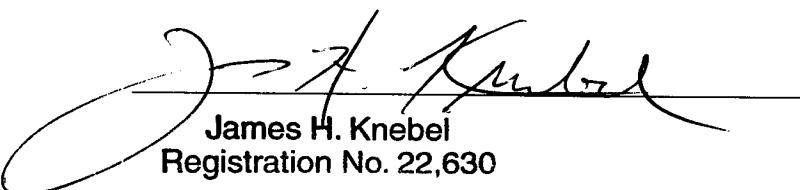
In the matter of the above-identified application for patent, notice is hereby given that the Applicant(s) claim as priority:

<u>Country</u>	<u>Application No.</u>	<u>Month/Day/Year</u>
JAPAN	2004-007824	01/15/2004
JAPAN	2004-106968	03/31/2004

Certified copies of the corresponding Convention Application(s) were submitted to the International Bureau in PCT Application Number PCT/JP05/000727, filed on 01/14/2005. Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached copy of form PCT/IB/304.

Respectfully Submitted,

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